



XA-10297 *IFW*

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Mitsuhiro YANARI

Appln. No.: 10/530,403

Group Art Unit: 2872

Filed: April 7, 2005

For: OPHTHALMIC LENS DESIGN METHOD, OPHTHALMIC LENS
MANUFACTURING METHOD AND COMPUTER PROGRAM

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

Documents AB-AC and AJ were cited in the International Search Report (copy attached).

Respectfully submitted,

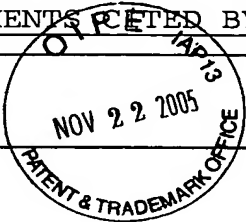
MWS:skw

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By:

Mitchell W. Shapiro
Mitchell W. Shapiro
Reg. No. 31,568

November 22, 2005

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT LIST OF DOCUMENTS CITED BY APPLICANT				Atty. Docket No. XA-10297		Appln. No. 10/530,403	
				Applicant Mitsuhiro YANARI			
				Filing Date April 7, 2005		Group 2872	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	4,613,217	09/23/1986	Fuerter et al.	351	176	
	AB	2002/0018178	02/14/2002	Shirayanagi et al.	351	177	
	AC	2002/0039171	04/04/2002	Shtrayanagi et al.	351	159	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	0 886 166	12/23/1998	Europe			
	AK						
	AL						
	AM						
	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
	AP						
	AQ						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							